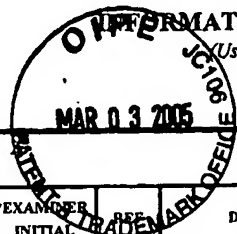
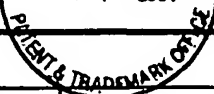


INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i> <div style="text-align: left; margin-top: 10px;">  </div>				Docket Number (Optional) YPL-0076		Application Number 10/763,694		
				Applicant(s) Hyeong-sop SHIM, et al.				
				Filing Date 1/23/2004		Group Art Unit 1743 1631		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
CS		6,300,063	10/9/2001	Lipshutz et al.	435	6	5/8/1997	
CS		6,027,880	2/22/2000	Cronin et al.	435	6	10/10/1995	
U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
CS		Office Action of Korean Patent Office regarding corresponding Korean Patent Applicatin No. 10-2003-0005025, dated 12/23/2004						
EXAMINER				DATE CONSIDERED				
/Carolyn Smith/				02/27/2007				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

INFORMATION DISCLOSURE CITATION

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APR 29 2004



Docket Number (Optional)

YPL-0076

Application Number

10/763,694

Applicant(s)

Hyeong-sop Shim, et al.

Filing Date

1-23-2004

Group Art Unit

1631

~~NTA~~

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
CS		2003-0020232	3-8-2003	KOREA			abstract	
CS		2003-0072709	9-19-2003	KOREA			abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

CS		"Applied Logistic Regression"; Second Edition; Authors: David W. Hosmer and Stanley Lemeshow; Wiley Series in Probability and Statistics; Pgs. 1-30, 2000.

EXAMINER /Carolyn Smith/

DATE CONSIDERED

02/27/2007

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